

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT (Under 37 CFR 1.97(b) or 1.97(c))			Docket No. 14872
In Re Application Of: Toshimichi Kurihara, et al.			
Serial No. 09/942,445	Filing Date August 30, 2001	Examiner Nema O. Berezny	Group Art Unit 2813
Title: SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF			
<div style="text-align: center;">Address to: Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450</div> <div style="text-align: center;">37 CFR 1.97(b)</div> <div>1. <input type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.</div> <div style="text-align: center;">37 CFR 1.97(c)</div> <div>2. <input checked="" type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of: <div style="margin-left: 40px;"><input checked="" type="checkbox"/> the statement specified in 37 CFR 1.97(e);</div><div style="text-align: center; margin: 10px 0;">OR</div><div style="margin-left: 40px;"><input type="checkbox"/> the fee set forth in 37 CFR 1.17(p).</div></div>			

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Docket No.
14872

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SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF



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